Motivation

- A glimpse of the (long) History of ABALONE
- Prototyping: FACTORY PROTOTYPE vs.
 PROTOTYPE FACTORY

NOW: our factory prototype = prototype factory

First Prototype Assembly

Collaborators

- Eckart Lorenz
- UC Davis: D. Ferenc, A. Chang, D. Johnson, J. Thomson (simulations, overall design, assembly, components, patent protection)
- U Wisconsin (since March 2011):: T. Montaruli. M. Duvernois, I. Wischer, K. Jero (GEANT, readout, components)
- U. of Split and Rijeka: D. Ferenc, D. Dominis, I. Puljak, N. Godinovic (transport system design and manufacture, simulations, readout)





NEED TO CONCENTRATE INFORMATION BY FACTOR 1000 – 100,000

VACUUM WILL STAY WITH US FOR QUITE A WHILE Photocthode = the cheap(est?) semiconductor

ABALONE

NOVEL MASS-PRODUCTION TECHNOLOGY and a novel design that allows full implementation of that technology

> →PATENT PENDING & LOTS OF KNOW-HOW Will reveal all secrets !

ABALONE

NOVEL MASS-PRODUCTION TECHNOLOGY and a novel design that allows full implementation of that technology

→PATENT PENDING & LOTS OF KNOW-HOW Will reveal all secrets ! The day after other companies do so.



as a FLAT PANEL PHOTOSENSOR WITHOUT DEAD AREA

ARRAYS OF "hex-paraboloid-hemispheres"







IceCube OPTICAL MODULE

ABALONE





NO PMT !!!

NO DYNODES NO VOLTAGE DIVIDER NO ELECTRODES NO uMETAL ~NO <u>MANU</u>-FACTURE MASS-PRODUCTION, SCALLABLE EXTREME ROBUSTNESS (mech, el.) ~100% COLLECTION EFFICIENCY

etc.

IceCube OPTICAL MODULE

The 4-PI ABALONE IceCube DREAM





ABALONE







WITH A FINE TOUCH OF A GENIUS





Development of Other Vacuum Devices





~1960

~2000

Production Cost '11 < \$300/m²

LOOKING FORWARD FOR IMPROVEMENTS But not critical

ENCLOSURE: FLAT-PANEL TV



MAJOR MODIFICATIONS

PHOTON→ELECTRON CONVERSION: CLASSICAL PHOTOCATHODE ALREADY VERY GOOD 3 existing mass-production technologies

INFORMATION

CONCENTRATOR

ELECTRON DETECTION: SEMICONDUCTOR Scintillator + Geiger-MODE AVALANCHE DIODE 'Light Amplifier'

TOM YPSILANTIS et al., AQUARICH CONCEPT (also development for LHCb)



D.F., Imaging Hybrid Photon Detectors with Minimized Dead Area and Protection Against Positive Ion Feedback. Nuclear Instruments and Methods in Physics Research <u>A431(1999)460-</u>







www.elsevier.nl/locate/nima

Imaging hybrid photon detectors with minimized dead area and protection against positive ion feedback

Daniel Ferenc*

Div. PPE, CERN, 1211-Geneva, 23 Switzerland

Received 15 December 1998

Abstract

Imaging Hybrid Photon Detectors (HPD) have been developed for integration in large area Cherenkov detectors for high-energy physics and astrophysics. The presented designs – developed particularly for the experiments MAGIC, LHCb and AQUA-RICH – comprise very good imaging properties, protection against positive ion feedback and(or) minimum dead area. The underlying innovations are discussed in some detail. © 1999 Published by Elsevier Science B.V. All rights reserved.

Keywords: Ion feedback; Dead area; RICH detectors; Atmospheric Cherenkov telescopes; Photon detectors; Gamma ray astronomy; High-energy physics



Fig. 1. Proximity focusing 5 in diameter UDD. Photoelectrons

ion recover protection has



Instruments and Methods in























6 MONTHS

+10 years it took us to reach the technological point where it became possible

0

+HV



MASS-PRODUCTION TECHNOLOGY

The KEY: VACUUM PROCESSING

- MINIMUM # OF MASS-PRODUCED (MOLDED) GLASS ELEMENTS (3)
- ASSEMBLY
 - CONTINUOUS VACUUM PRODUCTION LINE
 - SUPER-SIMPLE
 - SUPER-FAST
 - SUPER-CHEAP (FACTOR 20 less than PMT)

→ NO METAL ELEMENTS ← → NO CERAMICS ←

→ ABALONE









MASS-PRODUCTION - 1 COMPRESSION MOLDING







MASS-PRODUCTION - 2

CONTINUOUS VACUUM PRODUCTION LINE – MINI-PROTOTYPE FACTORY EXISTS @ UCD !!! ULTRAFAST, FULLY CONTROLLED : THIN-FILM MATERIAL DEPOSITION INCLUDING PHOTOCATHODE !!!!

ReFerence Flat-Panel 7-pixel









EXTREMELY IMPORTANT WE HAVE MASTERED THE OXIDE-FREE GLASS-TO-GLASS SEALING TECHNIQUE AND ON SMALL SURFACES (~2 mm)



PREREQUISITE FOR ABALONE WE HAVE CONDUCTED MANY TESTS, INCLUDING DESTRUCTIVE ONES (this windowlet is still sealing vacuum):











HAMAMATSU

FAST DECAY PHOSPHOR J9758

Clic Cor and

For Electron Beam Detection, High Speed and Long Life Phosphor

FEATURES

High Speed Decay (Decay Time: 2.3 ns)
Long Life
High Brightness Efficiency



APPLICATIONS

Semiconductor Inspection Instrument
 SEM (Scanning Electron Microscopy)
 Mass Spectrometry
 General Electron Detection

SPECIFICATIONS

GENERAL

| Parameter | Description/Value | Unit |
|--|-------------------|------|
| Dimensional Outline® | ♦9.0 mm × 0.5 mm | |
| Detection Energy Range (Electron beam) | 5 to 12 | keV |
| Decay time (90 % to 10 %) Typ. | 2.3 | ns |
| Peak Emission Wavelength | 400 | nm |
| Electrode Thickness (Aluminum) | 50 | nm |
| Operating Temperature Range | +5 to +45 | °C |

Applicable maximum size is \$50 mm.

NOTE: Custom assembly of light guide or vacuum flange is available upon request.

COMPARISON OF OTHER PHOSPHOR

| Phosphor | Decay Time (90 % to 10 %) | Relative Intensity (DC) | Life |
|---------------------------|------------------------------|-------------------------|---------|
| Fast Decay Phosphor J9758 | 2.3 ns | 100 | Good |
| P47 Phosphor | 100 ns | 160 | Good |
| YAP | 30 ns | 30 | Good |
| Plastic Scintillator | 5 ns | 25 | No good |

(a) Relative value with output from Fast Decay Phosphor J9758 set as 100, measured by HAMAMATSU Si Photodiode (S1337-BQ).

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SIGNIFICANTLY UPGRADED FACTORY SUPERB VACUUM IN 5 UHV CHAMBERS



SUPERB CONTROL – e.g. MASS SPECTROMETERS ON EACH CHAMBER







FIRST SPINOFF









THE FUTURE OF ABALONE

• OUR COMMUNITY SHOULD RECOGNIZE THE POTENTIAL OF ABALONE AND SUPPORT IT ON ALL LEVELS

- THE ABALONE <u>TECHNOLOGY</u> IS
 <u>VERY SIMILAR</u> TO MODERN SEMICONDUCTOR AND TV-PANEL TECHNOLOGY
 <u>VERY DIFFERENT</u> FROM PMT TECHNOLOGY
- PATENT PENDING (GUARANTEE FOR INVESTORS)
- STARTUP COMPANY FORMATION UNDER WAY